



## **UPLFLN10X2PH**

Product name	UPLFLN10X2PH
Product number	N5703700
UPC code	1-U2C5242
Image	
Dimension	#804 #804 #805 #805 #805 #805 #805 #805 #805 #805
Inquiry	Contact us
Web Store	Buy Now
Product number	N5703700
UPC code	1-U2C5242
Major application	• Life Science
Magnification [X]	10
magninoation [A]	10
Numerical aperture (NA)	0.3
Numerical aperture (NA)	0.3
Numerical aperture (NA) Working distance (WD) [mm]	0.3 10
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]	0.3 10 26.5
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]	0.3 10 26.5
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium	0.3 10 26.5 - Air/Dry
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded	0.3 10 26.5 - Air/Dry N/A
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar	0.3 10 26.5 - Air/Dry N/A N/A
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar  Iris	0.3 10 26.5 - Air/Dry N/A N/A N/A
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar  Iris  Correction level of chromatic aberration	0.3 10 26.5 - Air/Dry N/A N/A N/A Semiapochromat (FL)
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar  Iris  Correction level of chromatic aberration  Parfocalizing distance [mm]	0.3 10 26.5 - Air/Dry N/A N/A N/A Semiapochromat (FL) 45
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar  Iris  Correction level of chromatic aberration  Parfocalizing distance [mm]  Back focal plane (BFP) position [mm]	0.3 10 26.5 - Air/Dry N/A N/A N/A Semiapochromat (FL) 45 -19.1
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar  Iris  Correction level of chromatic aberration  Parfocalizing distance [mm]  Back focal plane (BFP) position [mm]  Type of screw thread	0.3 10 26.5 - Air/Dry N/A N/A N/A Semiapochromat (FL) 45 -19.1 W20.32×0.706 (RMS)
Numerical aperture (NA)  Working distance (WD) [mm]  Objective field number [mm]  Cover glass thickness [mm]  Immersion medium  Spring loaded  Correction collar  Iris  Correction level of chromatic aberration  Parfocalizing distance [mm]  Back focal plane (BFP) position [mm]  Type of screw thread  Brightfield (Reflected)	0.3 10 26.5 - Air/Dry N/A N/A N/A Semiapochromat (FL) 45 -19.1 W20.32×0.706 (RMS) N/A

Last updated: Aug 01 2023 Specifications, design and accessories are subject to change without any notice or obligation on the part of the manufacturer.



## **Data Sheet**

## UPLFLN10X2PH

DIC (Reflected)	N/A
DIC (Transmitted)	Limitation
Phase contrast	Excellent
Relief contrast	N/A
Polarization	Limitation
Fluorescence (B, G excitation)	Good
UV fluorescence (at 365 nm)	Good
Multiphoton	N/A
TIRF	N/A
IR	N/A
WLI	N/A
Auto focus	Yes

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